



ZfK

Patent
Attorney's Docket No. 1018765-000143

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	MAIL STOP ISSUE FEE
Akio Kikkawa et al.)	Group Art Unit: 1754
Application No.: 10/633,552)	Examiner: Wayne A Langel
Filed: August 5, 2003)	Confirmation No.: 6666
For: PROCESSING METHOD FOR HIGH)	
PRESSURE GAS CONTAINER AND)	
HALOGEN CONTAINING GAS)	
FILLED IN SAID CONTAINER)	

SUBMISSION OF INFORMATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of MPEP §609.04(b), please place in the file of the above-identified patent application the attached copy of U.S. Patent No. 5,803,795. The Korean counterpart patent of the '795 patent (KR 1997-5530) was cited by the Korean Examiner in the corresponding Korean patent application.

Should there be a need to discuss any aspect of the present application, the undersigned attorney may be contacted at the number provided below.

Respectfully submitted,

BUCHANAN INGERSOLL PC

Date: February 6, 2006

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